

<b>Notice of References Cited</b>	Application/Control No. 10/533,677		Applicant(s)/Patent Under Reexamination DE LUCA ET AL.	
	Examiner JEONG S. PARK		Art Unit 2454	Page 1 of 1

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*	B	US-2002/0143961	10-2002	Siegel et al.	709/229
*	C	US-2003/0065662	04-2003	Cosic, Jasmin	707/9
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#### NON-PATENT DOCUMENTS

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